

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/714,759	TAKAHASHI ET AL.		
Examiner	Art Unit		
John T. Kwon	3747		

SEARCHED					
Class	Subclass	Date	Examiner		
123	361	7/18/2005	JK		
	376				
	377				
	399				
	400				
	Updated	2/1/2006	JK		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
		DATE	EXMR
east		7/18/2005	JK